

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Michiaki Sakamoto, et al.

Serial No.: 09/870,749

Group Art Unit: 2871

Filing Date: June 1, 2001

Examiner: Ton, Minh Toan  
ACTIVE MATRIX LIQUID CRYSTAL DISPLAY DEVICE

For: Honorable Commissioner of Patents  
Alexandria, VA 22313-1450



RECEIVED  
JUN 10 2003  
2800 MAIL ROOM

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following documents cited in the Korean Office Action and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner.

In compliance with the requirements of 37 CFR §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of portions of an official action by a foreign examiner in which the references are cited. The relevance to the pending U.S. patent application is that the references was cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made, the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,



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<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>			Docket Number (Optional) <b>NEC01P012-JTb</b>		Application Number <b>09/870,749</b>		
			Applicant(s) <b>Michiaki Sakamoto, et al.</b>		Filing Date <b>June 1, 2001</b>		Group Art Unit <b>2871</b>
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
 <b>JUN 03 2003</b>							
<b>TO 2871 C MAIL ROOM</b> <b>JUN 10 2003</b>							
<b>FOREIGN PATENT DOCUMENTS</b>							RECEIVED
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	2000-66237	03/03/2000	Japan			ABS	
	6-347766	12/22/1994	Japan			ABS	
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
<b>Korean Office Action dated March 22, 2003 with Japanese Translation and Partial English Translation.</b>							
EXAMINER				DATE CONSIDERED			